

3011 U.S. PRO  
10/024307  
12/21/01

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

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APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10024307	12/21/2001	451	036	3723	Berry Morgan

\*\*APPLICANTS: Takashima Masayuki; Ueda Kazumasa;

\*\*CONTINUING DATA VERIFIED:

\*\* FOREIGN APPLICATIONS VERIFIED:

JAPAN 2000-399684 12/28/2000

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☒ yes ☐ no

35 USC 119 conditions met ☒ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

2185-0599P

TITLE : Polishing pad, polishing apparatus and polishing method using the same

U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>Assistant Examiner</b>	<b>CLAIMS ALLOWED</b>			
			<b>Total Claims</b>	<b>Print Claim for O.G.</b>		
<b>ISSUE FEE</b>		<b>Primary Examiner</b>	<b>DRAWING</b>			
<b>Amount Due</b>	<b>Date Paid</b>		<b>Sheets Drwg.</b>	<b>Figs. Drwg.</b>	<b>Print Fig.</b>	
<input type="checkbox"/> <b>TERMINAL</b>		<b>PREPARED FOR ISSUE</b>	<b>Applicant's Examiner</b>			
<b>DISCLAIMER</b>		<b>WARNING:</b> The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.				

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